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AMENDMENT UNDER 37 CFR 1.116 **EXPEDITED PROCEDURE – EXAMINING GROUP 2800** 

Attorney Docket No.: 16869P-041800US

Client Ref. No.: 210100244US1

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Not grand IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

AKIRA HAMAMATSU et al.

Application No.: 10/082,593

Filed: February 22, 2002

For: SEMICONDUCTOR DEVICE

INSPECTION METHOD

Customer No.: 20350

Confirmation No. 5740

Examiner: Hoa B. Trinh

Art Unit:

2814

AMENDMENT UNDER 37 CFR 1.116

EXPEDITED PROCEDURE **EXAMINING GROUP 2800** 

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Examiner:

In response to the Final Office Action mailed July 11, 2006 on the abovereferenced application, please enter the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.